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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q63680

Kohei ABUKAWA

Appln. No.: 09/821,020

Group Art Unit: 1775

Confirmation No.: 5550

Examiner: Archene Turner

Filed: March 30, 2001

For: **SILICON NITRIDE MEMBER, METHOD FOR MANUFACTURING THE SAME, AND CUTTING TOOL**

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three months, extending the time for responding to the Office Action of February 27, 2004 to August 27, 2004.

A check for the statutory fee of \$950.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Respectfully submitted,

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Date: August 26, 2004